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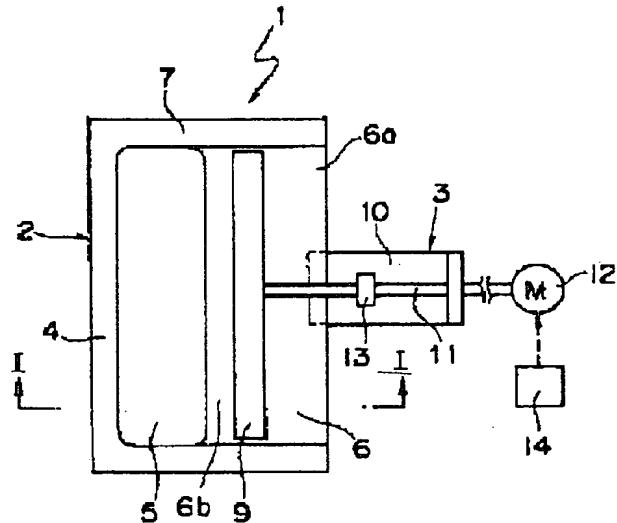
APPLICATION DATE : 02-10-95  
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APPLICANT : CHUGAI RO CO LTD;

INVENTOR : WATANABE HIROYUKI;

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TITLE : CRUCIBLE MECHANISM OF  
CONTINUOUS VACUUM DEPOSITION  
DEVICE



ABSTRACT : PROBLEM TO BE SOLVED: To provide a crucible mechanism of a continuous vacuum deposition device capable of charging a preheated material to be evaporated to a crucible.

SOLUTION: In the crucible mechanism 1 of the continuous vacuum deposition device having the crucible 2 in which a powdery, particulate or pellet-like material S to be evaporated is housed, the crucible 2 is composed of a main body part 4 having a concave part 5 in which the material S to be evaporated is housed and a mounting part 6 on which the material S to be evaporated is mounted, and a pusher mechanism 3 supplying the material S to be evaporated to the concave part 5 is provided near the crucible 2.

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